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OFFICIAL**facsimile transmittance**
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CENTRAL FAX CENTER**AUG 23 2004****To: Examiner Olivia T. Luk****Fax: 703-872-9306****From: Mag Chappuis****Date: August 23, 2004****E-mail: Mchappuis@atmi.com****Pages: 5****Re: RESPONSE TO JULY 11, 2003 OFFICE ACTION IN UNITED STATES PATENT APPLICATION SERIAL NO. 10/065,302****GROUP ART UNIT: 2812****TITLE: Composition and Chemical Vapor Deposition Method for Forming Organic Low K Dielectric Films****Dear Examiner Luk:****Please find attached a copy of the response to the July 30, 2003.****including:**

Original July 30, 2003 Response:	3 sheets
Original July 30, 2003 Facsimile Transmittal	1 sheet
Facsimile Transmittal Communication showing transmission of 4 sheets	1 sheet
Facsimile Transmittal August 23, 2004	1 sheet

Please call 203-739-1435 if there are any problems with this transmittal.**Maggie Chappuis**

ATMI, Inc.
7 Commerce Drive
Danbury, CT 06810
203-794-1100 (telephone)
203-797-2544 (facsimile)
ATMI Docket: ATM-466

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facsimile transmittance

To:	Examiner Olvin T. Luk	Fax:	703-746-8802
From:	Mag Chappuis	Date:	July 30, 2003
E-mail:	Mchappuis@atmi.com	Pages:	4

Re: RESPONSE TO JULY 11, 2003 OFFICE ACTION IN UNITED STATES PATENT APPLICATION SERIAL NO. 10/065,302

GROUP ART UNIT: 2812

TITLE: Composition and Chemical Vapor Deposition Method for Forming Organic Low K Dielectric Films

Dear Examiner Luk:

Please find attached the Response identified above, including:

Response: 3 sheets
Facsimile Transmittal 1 sheet

Please call 203-794-1100 ext. 4184 if there are any problems with this transmittal.

Maggie Chappuis

ATMI, Inc.
7 Commerce Drive
Danbury, CT 06810
203-794-1100 (telephone)
203-797-2544 (transmit)
ATMI Docket: ATM-444

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ATMI-466
Customer ID No.: 25559**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re United States Patent Application of:)	
Applicants: Neil H. Hendricks)	
Serial No.: 10/065,302)	Group Art Unit: 2812
Date Filed: October 1, 2002)	Examiner: Olivia T. Luk
Title: COMPOSITION AND CHEMICAL)	
VAPOR DEPOSITION METHOD FOR)	
FORMING ORGANIC LOW K DIELECTRIC)	
FILMS)	

FACSIMILE TRANSMISSION CERTIFICATE

It hereby is certified by the person identified below that this paper is being facsimile transmitted by such person to the Commissioner of Patents and Trademarks on the date specified, to the Assistant Commissioner for Patents, Washington, DC 20231, and Transmitted by Facsimile under the provisions of 37 CFR 1.6(d).


Maggie Chappuis

July 30, 2003
Date of Transmission

703-746-8802
Facsimile Number

**RESPONSE TO JULY 11, 2003 OFFICE ACTION IN
U.S. PATENT APPLICATION 10/065,302**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 11, 2003 in the above-identified application, wherein a restriction requirement was imposed against the following claim groups: